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FAX COVER SHEET

To: Commissioner for Patents

From: Robert M. Wallace

To: Office of Initial Patent

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Total Pages, including cover letter: 5

FAX NUMBER: 703-746-9195

Document Transmitted: REQUEST FOR CORRECTION OF FILING RECEIPT

Applicant: Kenneth S. Collins, et al. Examiner: Unknown

Serial No.: 10/646,612

Group Art Unit: 1763

Filed: August 22, 2003

Docket No.: 6915 P04

Title: PLASMA IMMERSION ION IMPLANTATION PROCESS USING A CAPACITIVELY COUPLED PLASMA SOURCE HAVING LOW DISSOCIATION AND LOW MINIMUM PLASMA VOLTAGE

I hereby certify that this paper is being transmitted by facsimile to the United States Patent & Trademark Office on the

Printed Name; Shelly Hagt

Signature/

PATENT

Attorney Docket No. 6915 P04 RW Ref. No. APM/001-02-CP4

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of:
 Kenneth S. Collins, et al.

Entitled: PLASMA IMMERSION ION
 IMPLANTATION PROCESS USING A
 CAPACITIVELY COUPLED PLASMA
 SOURCE HAVING LOW DISSOCIATION
 AND LOW MINIMUM PLASMA VOLTAGE

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Output

Description: 10/646,612

REQUEST FOR CORRECTION OF FILING RECEIPT

OFFICE OF INITIAL PATENT EXAMINATION'S CUSTOMER SERVICE CENTER FAX NO.: 703-746-9195

Sir:

Applicants hereby request issuance of a new filing receipt in the above-referenced patent application to change the Attorney Docket Number as identified on the Filing Receipt dated November 18, 2003. Please note the changes highlighted on the enclosed copy of the Filing Receipt. Specifically, the corrections are as follows:

The attorney docket number should read as 6915 P01. The Attorney Docket Number is currently represented as 008401.

The title of the invention is incorrectly spelled. The word "having" in the title of the invention is incorrectly spelled as "haivng".

Applicants respectfully request the Patent Office to correct the Filing Receipt and forward copy to Applicant.

If the Examiner should have any questions regarding the above correction, the Examiner is requested to telephone Applicant's representative at the number listed below.

Respectfully submitted, ·

Robert M. Wallace

Reg. No. 29,119

Attorney for Applicant(s)

Please direct all telephone calls to:

Mr. Robert M. Wallace Patent Counsel (805) 644-4035

Please continue to send all correspondence to:

Patent Counsel, M/S 2061 Legal Affairs Dept. Applied Materials, Inc. P.O. Box 450A Santa Clara, CA 95035



APPL NO.

10/646,612

United States Patent and Trademark Office

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FILING OR 371 ART UNIT FIL FEE REC'D ATTY.DOCKET NO (c) DATE DRAWINGS TOT CLMS IND CLMS 08/22/2003 1763 0.00 008401 04

CONFIRMATION NO. 8623

FILING RECEIPT

OC000000011314584

Patent Counsel, M/S 2061 Legal Affairs Dept. Applied Materials, Inc. P.O. Box 450-A Santa Clara, CA 95035

JAN 1 6 2004

Date Mailed: 11/20/2003

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MICHAELSON & WALLACE

Receipt is acknowledged of this regular Patent Application. It will be considered in its order and you will be notified as to the results of the examination. Be sure to provide the U.S. APPLICATION NUMBER, FILING DATE. NAME OF APPLICANT, and TITLE OF INVENTION when inquiring about this application. Fees transmitted by check or draft are subject to collection. Please verify the accuracy of the data presented on this receipt. If an error is noted on this Filing Receipt, please write to the Office of Initial Patent Examination's Filing Receipt Corrections, facsimile number 703-746-9195. Please provide a copy of this Filing Receipt with the changes noted thereon. If you received a "Notice to File Missing Parts" for this application, please submit any corrections to this Filing Receipt with your reply to the Notice. When the USPTO processes the reply to the Notice, the USPTO will generate another Filing Receipt incorporating the requested corrections (if

Applicant(s)

Kenneth S. Collins, Residence Not Provided; Hiroji Hanawa, Residence Not Provided; Kartik Ramaswamy, Residence Not Provided; Andrew Nguyen, Residence Not Provided; Amir Al-Bayati, Residence Not Provided; Biagio Gallo, Residence Not Provided; Gonzalo Antonio Monroy, Residence Not Provided;

Domestic Priority data as claimed by applicant

This application is a CIP of 10/164,327 06/05/2002

Foreign Applications

If Required, Foreign Filing License Granted: 11/19/2003

Projected Publication Date: To Be Determined - pending completion of Missing Parts

Non-Publication Request: No

Early Publication Request: No

Title

Plasma immersion ion implantation process using a capacitively coupled plasma source haiving low dissociation and low minimum plasma voltage

Preliminary Class

156

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